

# 10/Decl.  
4-1-03  
Hayeo

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Kazuhiro IKURUMI et al.

Serial No.: 09/826,827

Filed: April 6, 2001

For: METHOD AND APPARATUS FOR ADJUSTING IMPEDANCE OF  
MATCHING CIRCUIT

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DECLARATION

Assistant Commissioner for Patents,  
Washington, D.C.

Sir:

I, Mitsuo WADA, of AOYAMA & PARTNERS, located at IMP Building, 1-3-7, Shiromi, Chuo-ku, Osaka 540-0001, Japan, a translator, herewith declare:

(1) that I know well both the Japanese and English languages;

(2) that I am presently engaged as a translator in these languages;

(3) that the attached document represents a true English translation of Japanese Patent Application No. 2000-106563; and

(4) that all statements made of my own knowledge are true and that all statements made on information and belief are believed to be true, and further that these statements are made with the knowledge that willful false

statements and the like are punishable by fine or imprisonment, or both, under 18 USC 1001, and that such false statements may jeopardize the validity of the application or any patent issuing thereon.

Signed this twelfth day of March, 2003.

A handwritten signature in black ink, consisting of a large, stylized 'M' followed by a horizontal line and a small flourish.

Mitsuo WADA

PATENT OFFICE  
JAPANESE GOVERNMENT

This is to certify that the annexed is a true copy of the  
following application as filed with this Office.

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Date of Application: April 7, 2000

Application Number: Patent Application No. 2000-106563

Applicant(s): Matsushita Electric Industrial Co., Ltd.

April 13, 2001

Kozo OIKAWA  
Commissioner,  
Patent Office

(seal)

Reg. No. 2001-3030357

Document Name: Application for Patent

Docket No.: 167669

Date of Application: April 7, 2000

Addressee: Commissioner, Patent Office

International Patent  
Classification: H03H 7/00

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Appointed Patent Attorney:

Identification No.: 100086405

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Appointed Patent Attorney:

Identification No.: 100091524

Name: Mitsuo WADA

JP2000-106563

Payment of Fees:

Prepayment Book No.: 013262  
Amount to be paid: 21,000 yen

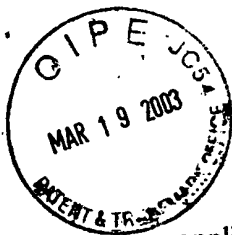
Attached document(s):

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Item: Specification	1 copy
Item: Drawings	1 copy
Item: Abstract	1 copy

Registration No.  
of General Power: 9602660

Request for proof  
transmission: Yes



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

# 11/dmwp  
4-1-03  
Hayes

In re application of

Kazuhiro IKURUMI et al.

Serial No. 09/826,827

Filed April 6, 2001

: Confirmation No. 5095

: Docket No. 2001\_0409A

: Group Art Unit 2817

: Examiner Justin P. Bettendorf

METHOD AND APPARATUS FOR  
ADJUSTING IMPEDANCE OF  
MATCHING CIRCUIT

SUBMISSION OF FORMAL DRAWINGS

Assistant Commissioner for Patents,  
Washington, DC 20231

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEES FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975

Sir:

In accordance with Patent Office practice, submitted herewith are formal drawings for  
Figs. 1-35 (19 sheets, A4 Paper) as required by the Examiner.

Respectfully submitted,

Kazuhiro IKURUMI et al.

By:

David M. Ovedovitz

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March 19, 2003

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 5095**  
Kazuhiro IKURUMI et al. : **Docket No. 2001\_0409A**  
Serial No. 09/826,827 : **Group Art Unit 2817**  
Filed April 6, 2001 : **Examiner Justin P. Bettendorf**

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ADJUSTING IMPEDANCE OF  
MATCHING CIRCUIT

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FEES FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975

**LETTER RE PROPOSED DRAWING AMENDMENT**

Assistant Commissioner for Patents,  
Washington, D.C.

Sir:

Enclosed herewith is a photocopy of Fig. 33 marked in red to indicate proposed drawing amendment thereto.

The Examiner is requested to approve such proposed drawing amendment.

Respectfully submitted,

Kazuhiro IKURUMI et al.

By David M. Ovedovitz  
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